

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi IGARASHI et al.

Application No.:

Cont. Application of U.S. Application No. 09/784,014 filed
March 21, 2001

Filed: July 3, 2003

Docket No.: 108833.01

For: LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS
MEASUREMENT METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. The reference(s) was/were cited by or submitted to the Office in parent application No. 09/787,014, filed March 21, 2001, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Stephen P. Catlin
Registration No. 36,101

JAO:SPC/dap

Date: July 3, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
--

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 108833.01		APPLICATION NO. Cont. Appln. Of U.S. Appln. No. 09/787,014 filed 3/21/2001	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Takashi IGARASHI et al.			
				FILING DATE July 3, 2003		GROUP	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
		6,050,877	04-2000	SHIBATA et al.	451	5
		6,220,929B	04-2001	MIZUMO	451	43
		6,080,044A	06-2000	LANHAM et al.	451	42
		6,123,604	09-2000	MIZUNO et al.	451	42
		4,989,316A	02-1991	LOGAN et al.	451	42
		5,149,337A	09-1992	WATANABE	451	42
		6,012,965A	01-2000	SAVOIE	451	42
		6,276,994B	08-2001	YOSHIDA et al.	451	42
		6,099,383A	08-2000	MIZUNO et al.	451	43
		6,203,409B	03-2001	KENNEDY et al.	451	43
		5,993,295A	11-1999	RAFFAELLI	451	43
		5,775,973A	07-1998	WATANABE	451	43
		5,738,563A	04-1998	SHIBATA	451	43
		5,053,971A	10-1991	WOOD et al.	451	43
		5,882,247	03-1999	LONGUET et al.		
		4,115,956	09-1978	HUFFMAN		

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
		JP U 58-106112	07/19/1983	JAPAN (NO TRANSLATION)		
		JP A 4-315563	11/06/1992	JAPAN (NO TRANSLATION)		
		JP A 5-4156	01/14/1993	JAPAN (NO TRANSLATION)		
		JP A 5-131350 (w/abstract)	05/28/1993	JAPAN (NO TRANSLATION)		
		JP B2 8-16611 (w/abstract)	02/21/1996	JAPAN (NO TRANSLATION)		
		JP A 9-309051	12/02/1997	JAPAN (NO TRANSLATION)		
		JP A 9-309052 (w/abstract)	12/02/1997	JAPAN (NO TRANSLATION)		
		JP A 11-10427	01/19/1999	JAPAN (NO TRANSLATION)		
		JP A 11-28650	02/02/1999	JAPAN (NO TRANSLATION)		

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	